

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiko TSUJI et al.

New U.S. National Phase of PCT/JP2005/000228

Filed: June 29, 2006

Docket No.: 128591

For: AN EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

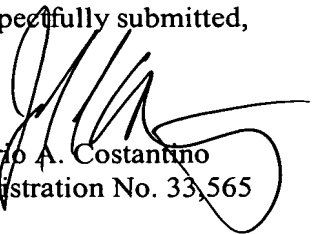
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 11-16 & 18-21.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 4-8.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. In accordance with the October 19, 2004 USPTO Official Gazette Notice, copies of pending U.S. patent applications filed on or after June 30, 2003, or entering the U.S. National Phase after June 30, 2003, are not attached.
- ☒ 6. An English language Abstract of one or more non-English language reference is attached hereto. See References 4-15 & 17-21.

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- ☒ 7. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 4-9, 12-16 & 18-21.
- ☒ 8. One or more co-pending U.S. patent application is identified on the attached Form PTO 1449. The Examiner is respectfully requested to consider each cited application and the art cited therein during examination of the present application.
- ☒ 9. References 1 & 2 correspond to reference 4. Reference 10 corresponds to reference 22.

Respectfully submitted,

  
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MAC:JSA/jdb

Date: June 29, 2006

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128591		APPLICATION NO. U.S. National Phase of PCT/JP2005/000228 <b>10/585001</b>	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Toshihiko TSUJI et al.			
				FILING DATE June 29, 2006			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	2005/0007574	1/13/2005	Van Der Meulen et al.			
	2	2004/0031932	2/19/2004	Vosters et al.			
	3	2005/0088635	4/28/2005	Hoogendam et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	4	JP A 2004-343120	12/2/2004	Japan	X	X	
	5	JP A 2002-227924	8/14/2002	Japan	X	X	
	6	JP A 2001-102286	4/13/2001	Japan	X	X	
	7	JP A 09-236151	9/9/1997	Japan	X	X	
	8	JP A 06-204108	7/22/1994	Japan	X	X	
	9	JP A 2002-373849	12/26/2002	Japan	X	X	
	10	WO 05/024921	3/17/2005	WIPO	X		
	11	WO 99/49504	9/30/1999	WIPO	X		
	12	JP A 06-124873	5/6/1994	Japan	X	X	
	13	JP A 10-303114	11/13/1998	Japan	X	X	
	14	JP A 10-163099	6/19/1998	Japan	X	X	
	15	JP A 10-214783	8/11/1998	Japan	X	X	
	16	JP A 2000-505958	5/16/2000	Japan		X	
	17	WO 98/28665	7/2/1998	WIPO	X		
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER						DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 29, 2006

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